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DATE MAILED: 10/20/2006

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/520,522 09/26/2005		Kazuo Miyashita	040894-1763	9262
9629 7	590 10/20/2006		EXAMINER	
	EWIS & BOCKIUS LLF LVANIA AVENUE NW	•	KASENGE, CHARLES R	
WASHINGTON, DC 20004		ART UNIT	PAPER NUMBER	
		2125		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	10/520,522	MIYASHITA, KAZUO			
Office Action Summary	Examiner	Art Unit			
	Charles R. Kasenge	2125			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period w  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin rill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D. (35 U.S.C. § 133).			
Status					
<ul> <li>1) ⊠ Responsive to communication(s) filed on 21 Ju</li> <li>2a) ☐ This action is FINAL. 2b) ⊠ This</li> <li>3) ☐ Since this application is in condition for allowar closed in accordance with the practice under E</li> </ul>	action is non-final. nce except for formal matters, pro				
Disposition of Claims					
<ul> <li>4)  Claim(s) 1-18 is/are pending in the application.</li> <li>4a) Of the above claim(s) is/are withdraw</li> <li>5)  Claim(s) is/are allowed.</li> <li>6)  Claim(s) 1-18 is/are rejected.</li> <li>7)  Claim(s) is/are objected to.</li> <li>8)  Claim(s) are subject to restriction and/or</li> </ul>	vn from consideration.				
Application Papers		•			
9) ☐ The specification is objected to by the Examine 10) ☑ The drawing(s) filed on <u>07 January 2005</u> is/are: Applicant may not request that any objection to the c Replacement drawing sheet(s) including the correct 11) ☐ The oath or declaration is objected to by the Ex	a) $\boxtimes$ accepted or b) $\square$ objected drawing(s) be held in abeyance. Se ion is required if the drawing(s) is ob	e 37 CFR 1.85(a). ejected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
<ul> <li>12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No</li> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>					
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 7/21/06,9/26/05.	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:	Pate			

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# **DETAILED ACTION**

# Information Disclosure Statement

1. The information disclosure statement filed 7/21/06 fails to comply with the provisions of 37 CFR 1.97, 1.98 and MPEP § 609 because it doesn't contain an explanation of relevance or a translation of the foreign documents KR 2000-0076601 and JP 3741562-B. It has been placed in the application file, but the information referred to therein has not been considered as to the merits. Applicant is advised that the date of any re-submission of any item of information contained in this information disclosure statement or the submission of any missing element(s) will be the date of submission for purposes of determining compliance with the requirements based on the time of filing the statement, including all certification requirements for statements under 37 CFR 1.97(e). See MPEP § 609.05(a).

# Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 1-18 are rejected under 35 U.S.C. 102(b) as being anticipated by Fargher et al.

  U.S. Patent 5,826,040. Regarding claim 1, Fargher discloses a production plan devising system for formulating a production plan by means of simulating movement of a product in a factory by an event-based simulator through use of a production process model and a production rule (col.

4, lines 16-36), the production plan devising system comprising: a time-interval-based simulator

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for computing the status of a production process at given time intervals (col. 7, lines 34-62); and a rule generator for automatically deriving the production rule through use of the time-interval-based simulator (col. 8, lines 45-54).

Regarding claims 2, 3 and 5, Fargher discloses the production plan devising system according to claim 1, wherein the production rule is formulated by means of a machine learning method based on a consecutive optimization technique using an artificial intelligence technique (col. 5, lines 17-25). Fargher discloses the production plan devising system according to claim 1, wherein the rule generator is constituted by a neural network (abstract see also Other Publications).

Regarding claim 4, Fargher discloses a production plan devising method for formulating a production plan by means of simulating movement of a product in a factory by an event-based simulator through use of a production process model and a production rule, the production plan devising method employing a time-interval-based simulator for computing the status of a production process at given time intervals and a rule generator for automatically deriving the production rule through use of the time-interval-based simulator (col. 4, lines 16-36), the production plan devising method comprising: a step for repeatedly devising a production plan over and over again by the time-interval-based simulator (col. 7, lines 34-62); a step for applying mechanical learning based on a consecutive optimization technique to the rule generator (col. 5, lines 17-25); a step for automatically formulating the production rule (col. 5, lines 50-58); a step for using a generated production rule by the event-based simulator; and a step for formulating a production rule (col. 6, lines 54-67).

Regarding claims 6, 10, 14 and 18, Fargher discloses a production system comprising: a

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simulator for repeatedly computing the amount of WIP in manufacturing processes (col. 7, lines 34-62); and a control system which determines a parameter to be used in computation of the simulator such that a computation result of the simulator becomes equal to an allowable range or less, and which controls the manufacturing processes on the basis of the parameter (col. 13, lines 7-16).

Regarding claims 7-9, 11-13 and 15-17, Fargher discloses the production system according to claim 6, wherein the simulator comprises: a time-interval-based simulator for computing the status of a production process at given time intervals, and a rule generator for automatically deriving the production rule through use of the time-interval-based simulator, and the simulator repeatedly computes the quantity of WIP in manufacturing processes through use of a production rule generated by the generator (col. 7, lines 34-62). Fargher discloses the production system according to claim 6, wherein the control system has measurement equipment for measuring the amount of actual WIP in manufacturing processes; and, when the amount of actual WIP measured by the measurement equipment within a given cycle has become equal to a computation result of the simulator, the control system suspends production in manufacturing processes and resumes production in the next cycle (col. 7, lines 34-62). Fargher discloses the production system according to claim 8, wherein the given cycle can be variably set (col. 7, lines 34-62).

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# Conclusion

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Charles R. Kasenge whose telephone number is 571 272-3743. The examiner can normally be reached on Monday through Friday, 8:30 - 5 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Leo Picard can be reached on 571 272-3749. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

CK

October 13, 2006

LEO PICARD SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2100

L-P.P